MÖNCH

Light collection and injection add-on for STEMs

Cathodoluminescence - Photoluminescence - Gain spectroscopy - Local thermal excitation

Benefit from a versatile system that includes both light collection or injection modes.

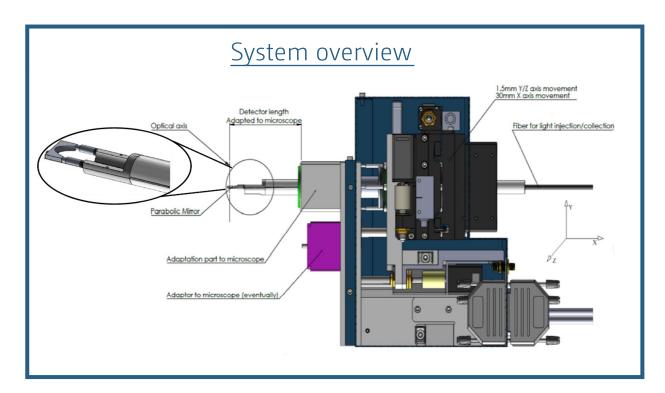Reveal unprecedent features of your sample: composition, structure and/or defects.

Take advantage from a fully optimized system with large collection angle.

Excite samples to reveal local behaviour under light/thermal exctation.

The Mönch is an easy to use and accurate add-on for light collection or injection in (S)TEM thanks to:

- A **mirror independent from the sample holder** allowing for a perfect and optimized alignment
- An absolute encoding system ensuring high alignment precision and reproducibility (100nm-precision)
- The ability to inject/collect light either in free space or via an optical fiber.

System overview

Light collection mode:

The Mönch has been designed and carefully optimized to achieve unprecedent signal-to-noise ratio thanks to:
- A **proprietary parabolic collection mirror** designed to fit into pole piece gap as small as 4.5mm;
- A **positioning system** with sub-micrometer precision for perfect alignment of the mirror with respect to the sample;
- A **high curvature parabolic mirror** with a NA > 0.4;
- A **working distance reduced to 300µm** to maximize the light collection/injection efficiency;
- A **patented asymmetric optical fiber** designed to preserve brightness and spectral resolution.
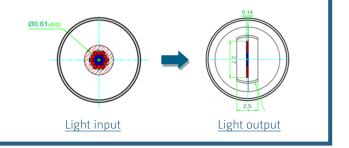
Light injection mode:

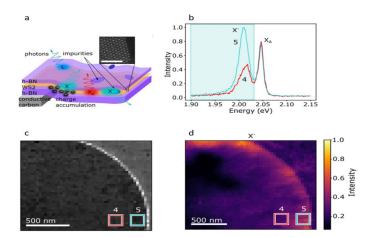The Mönch has been designed to reach unprecedent level of performances and versatility thanks to:
- A **beam size reduced to few microns** for localized light or thermal excitation of samples;
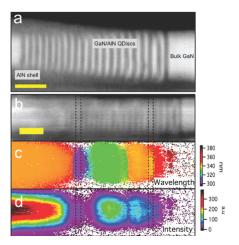- The ability to perform **injection and light collection measurements simultaneously**

Patented optical fiber:

The Mönch uses of an asymetric optical fiber with a bundle rearrangement from round to parallel to the entrance slit of the imaging spectrograph. This enables keeping constant spectral resolution even when the slit is opened and the spot moving at the entrance of the slit due to scanning.

Light input   Light output

a) h-BN/WS2/h-BN heterostructure shows three emission lines: excitons (XA), trions (X-) and localized emitters (L). b) CL spectra for the regions highlighted in c and d. c) HAADF region measured in d and d) the X- intensity map revealing local trion enhancement.
(Bonnet et al., avarXiv:2102.06140 (2021)).

Spectral imaging of a GaN/AlN NW with 20 QDisks (a) HAADF image of a GaN/AlN nanowire Scale bar is 20 nm. (b) HAADF of the NW, acquired simultaneously with the CL. (c) Wavelength position of the most intense peak. (d) Intensity of the most intense peak.
(L.Zagonel et al., Nano letters, 11(2), 568-573 (2011)

Light collection/injection modes

Mode	Typical excitation sources	Nature of analysis
Light collection Light collection after surface excitation	E-beam, Laser, Thermal, Electrical...	Cathodoluminence (light)
Light injection Electron imaging after light/thermal excitation	Laser	Electron imaging (electron) in photo emission/thermo-ionic regimes

Topics:

- Electronics & Optoelectronics (GaN, InP, SiC...)
- Photovoltaic cells (GaAs, CdTe, Perovskites...)
- Light emitting diodes (LEDs)
- 2D materials (Graphene, BN, WS2, diamond...)
- Noble metals (plasmonic)

- Photonic crystals
- Quantum wells & quantum dots
- Minerals, glasses, ceramics and gemstones)
- Inorganic coatings
- Organic, polymer samples

Mönch: Unique Light collection/injection add-on for STEM

High spectral resolution · High collection efficiency · Versatile and flexible system
Large choice of source, detectors, stages · Fast hyperspectral map measurement time
Low beam dosage · Can be used with sensitive samples · Unprecedent signal-to-noise ratio
Sub-micrometer alignment of mirror · High resolution images · Fits into small pole-piece gap
No compromise between brighness and spectral resolution · Compatible with other techniques (EELS, EDS...)

Mönch Features

Specifications

Mirror:

- Proprietary parabolic reflective mirror
- Thickness: 2.0 mm (other thicknesses on request)
- Compatibility for light collection and injection mode
- Sample to mirror distance : 300µm
- Mirrror reflection : up to 90% from 200nm to 1.7µm.

Micro-positionning system:

- Travel range: 30mm (X), +/-1.5mm (Y), +/-1.5mm (Z)
- Automated retractable mirror.
- Absolute encoders with 300nm-precision
- Stage touch alarm to avoid damaging pole pieces or sample holder
- Compact module : 161mm x 210mm x 133 mm
- Compatible with Thorlabs cage system

Light collection/injection couplings:

- Optical fiber with adapted insertion slot
- Free space to avoid loss of spatial coherence and degradation of signal power density
- *Switching between both modes takes few seconds*

System control:

- External scanning card with 4 inputs (12 bits) for additional single channel detectors (PMT...); 2 outputs for controlling the STEM scan (X and Y); 1 output for the beam blanker.
- Fastest measurement speed: 900Hz (18s for a 128x128 map)

Software:

- Arm/mirror control software (Windows® 10 or higher, 64 bits)
- Acquisition/visualisation module for Gatan Digital Micrograph
- Option: Python API scrypting

Options:

Dispersive spectrometer
- Two imaging exits (320 mm focal legnth)
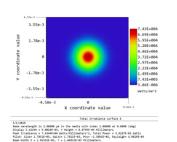- Large choice of gratings turret

Detectors

- High speed UV-Visible CCD camera (200 nm–1100 nm)
- InGaAs near infra-red camera (900 nm–1700 nm)
- Panchromatic detection (PMT; 200 nm–900 nm)
- *Others detectors on request*

Light injection : Beam size simulation

The specific mirror shape enables generating a micrometer beam spot size on the sample surface.
For a input laser beam diameter of 0.5mm, the beam spot size on the sample surface is approx. 2.0µm-diam.

Optical simulation:

STEM compatibility:

- Compatible with most of the (S)TEM models : JEOL, TFS/FEI, Hitachi, Nion VG...
- Pole-piece gap : minimum 4.5mm
- One available port in the PPG plane
- Contact us at : contact@attolight.com to check the compatibility of your (S)TEM models

About Attolight AG:

Attolight AG started off to revolutionise cathodoluminescence (CL) by designing top of the line CL instruments that deliver superior performance, maximum ease-of-use and makequantitative cathodoluminescence. The Company firmly believes in the potential of cathodoluminescence and aims at establishing the technology as a standard in-line inspection method in semiconductor industry.

Attolight AG is a company with global presence with systems in Europe, Asia, and North America. The Company headquartered at the EPFL Innovation Park where the Attolab is located as well.